



Attorney Docket SEL 238

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Hiroki et al.)
)
Serial No.: 09/776,472)
)
Filed: February 2, 2001)
)
For: Thin Film Formation Apparatus And)
Method Of Manufacturing Self-Light-)
Emitting Device Using Thin Film)
Formation Apparatus)
)
Art Unit: 1762)
)
Examiner: M. Cleveland)
)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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March 8, 2004

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace

3/8/04

Signature

Date

AMENDMENT D

Sir:

In response to the Office Action of November 6, 2003, a one month extension of time being submitted herewith, please amend the above-identified application as follows: